

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No. : 10/712,495 Group Art Unit: 1762
Filed : November 13, 2003 Inventor: Frank Jansen
Attorney Docket : M02A430 Examiner: Howard E. Abramowitz
Title : ATOMIC LAYER DEPOSITION PROCESS AND APPARATUS

**MAIL STOP: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

RESPONSE

Sir:

In response to the Office Action dated June 21, 2005, please amend the application identified above as follows.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: MAIL STOP: Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450
on: Sept 14, 2005

PHYLLIS SERVON
Printed name of person signing this certificate

Phyllis Servon
Signature of person mailing